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Date

PATENT

Atty. Docket No.: 006915 USA P02/FEP/P3I/AG
RW Ref. No.: APM/001-02-CP1-2



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Kenneth Collins, et al. :
:
Entitled: PLASMA IMMERSION ION :
IMPLANTATION APPARATUS USING A : Group Art Unit: 2813
PLASMA SOURCE HAVING LOW :
DISSOCIATION AND LOW MINIMUM :
PLASMA VOLTAGE :
:
Serial No.: 10/646,533 : Examiner: Jack S. Chen
:
Filing Date: August 22, 2003 :
:

RESPONSE TO DOUBLE PATENTING REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Double Patenting) dated January 9, 2008, applicants submit herewith a Terminal Disclaimer to overcome the double patenting rejection.

Although the claims have not been amended, a complete listing of claims is provided and begins on page 2.

Remarks begin on page 17 of this paper.